

SEP 08 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: BAYAN et al.

Attorney Docket No.: NSC1P274/P05649

Application No.: 10/650,325

Examiner: IM, Junghwa M.

Filed: August 27, 2003

Group: 2811

Title: SUBSTRATE FOR USE IN
SEMICONDUCTOR MANUFACTURING AND
METHOD OF MAKING SAME

Confirmation No.: 6886

CERTIFICATE OF FACSIMILE TRANSMISSIONI hereby certify that this correspondence is being transmitted
by facsimile to fax number 571-273-8300 of the U.S. Patent
and Trademark Office on September 8, 2005.Signed: 

Susan W. Xu

AMENDMENT C TRANSMITTALMail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

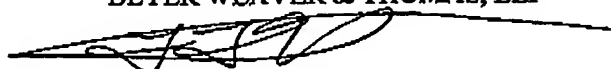
Sir:

Transmitted herewith is an Amendment in the above-identified application.

The fee has been calculated as shown below.

	Claims After Amendment		Highest Previously Paid For	Present Extra	Small Entity Rate Fee	Large Entity Rate Fee
Total Claims	31	MINUS	30	01	x 25 =	x 50 = \$50.00
Independent Claims	03	MINUS	4	00	x 100 =	x 200 = \$-0-
Multiple Dependent Claim Present and Fee Not Previously Paid					\$180.00	\$360.00
Total					\$	\$-0-

- ☒ Applicant(s) hereby petition for a 03 month extension(s) of time to respond to the
aforementioned Office Action.
- ☒ Applicant(s) believe that no (additional) Extension of Time is required; however, if it is
determined that such an extension is required, Applicant(s) hereby petition that such an extension
be granted and authorize the Commissioner to charge the required fees for an Extension of Time
under 37 CFR 1.136 to Deposit Account No. 50-0388 (Order No. NSC1P274).
- ☐ Enclosed is our Check No. _____ in the amount of \$_____ to cover the additional
claim fee and/or extension of time fees.
- ☒ Please charge the required fees, or any additional fees required to facilitate filing the
enclosed response, to Deposit Account No. 50-0388 (Order No. NSC1P274).

Respectfully submitted,
BEYER WEAVER & THOMAS, LLPFrancis T. Kalinski II
Registration No. 44,177P.O. Box 70250
Oakland, CA 94612-0250

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NO. 984 P. 5/21

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AMENDMENT C

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Dear Examiner Im:

The applicants request entry of this Amendment C along with the accompanying Request for Continued Examination. The Applicants would like to especially thank Examiner Im for discussing this case in the August 24, 2005 telephonic interview. In response to the Final Office Action dated March 11, 2005 and the Advisory Action of June 10, 2005, please amend the above-identified patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begin on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.

09/12/2005 MBINAS 00000027 500300 10650325
03 FC:1202 50.00 DA

NSC1P274/P05649

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